

520.34692V17

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: SORAOKA et al

Serial No.:

Filed: April 19, 2004

For: Vacuum Processing Apparatus And Semiconductor
Manufacturing Line Using The Same

Group: 3652

Examiner: T. Brahan

REAFFIRMATION OF CLAIM OF PRIORITY

Mail Stop: New Appln.
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

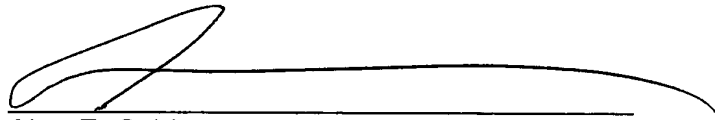
April 19, 2004

Sir:

Under the provisions of 35 USC 119, applicant hereby claims the right of
priority based on Japanese Patent Application No. 7-182921, filed July 19, 1995.

Respectfully submitted,

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